

Application No. 10/696,775
Attorney Docket No. 032076

Amendment under 37 C.F.R. §1.111

AMENDMENTS TO THE SPECIFICATION

Please amend the Title as follows:

**~~SEMICONDUCTOR DEVICE FABRICATION METHOD FOR FABRICATING~~
A SEMICONDUCTOR DEVICE INCLUDING THE USE OF A COMPOUND
CONTAINING SILICON AND NITROGEN TO FORM AN INSULATION FILM OF SiN,
SiCN OR SiOCN**